



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 3280

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/591,718	09/05/2006	355	1795	1608-7 PCT/US	
APPLICANTS Keita Ishiduka, Kanagawa, JAPAN; Kotaro Endo, Kanagawa, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/03903 03/07/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-063016 03/05/2004 JAPAN 2004-170424 06/08/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/07/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /CONNIE P. JOHNSON/ Acknowledged <u>Examiner's signature</u>		<input type="checkbox"/> Met after Allowance STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 0	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 1
ADDRESS HOFFMANN & BARON, LLP 6900 JERICHO TURNPIKE SYOSSET, NY 11791 UNITED STATES					
TITLE Positive-type resist composition for liquid immersion lithography and method for forming resist pattern					
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		